

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Confirmation No.: 3488
Shinji MAEKAWA et al.)
Application No. 10/579,800) Examiner: Hoai V. Pham
Filed: May 19, 2006) Group Art Unit: 2892
For: METHOD FOR MANUFACTURING)
SEMICONDUCTOR DEVICE)

REQUEST FOR RECONSIDERATION

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed April 23, 2009, Applicants respectfully request reconsideration and allowance of the above-identified application in view of the following remarks.